

Docket No. 206276US2

IN RE APPLICATION OF: Toshiki WATANABE

SERIAL NO: 09/839,294

FILED: April 23, 2001

FOR: EXPOSURE CONTROL APPARATUS AND METHOD THEREOF



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ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Transmitted herewith is an amendment in the above-identified application.

- ☒ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☒ Additional documents filed herewith: Letter Requesting Approval of Substitute Drawings (Figs. 6 and 9)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	11	MINUS	20	0	× \$18 =	\$0.00
INDEPENDENT	3	MINUS	3	0	× \$80 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$270 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
		TOTAL				\$0.00

- ☐ A check in the amount of _____ is attached.
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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Docket No.: 206276US2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Toshiaki WATANABE

: EXAMINER:

SERIAL NO. : 09/839,294

:

FILED: April 23, 2001

: GROUP ART UNIT:

FOR: EXPOSURE CONTROL
APPARATUS AND METHOD
THEREOF

LETTER REQUESTING APPROVAL OF SUBSTITUTE DRAWINGS

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Please review for approval the substitutes for Figures 6 and 9 in the enclosed
drawings.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



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GJM/SS/ALP:pch

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